

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
		:	Examiner: A. Rodriguez
TADAHIRO OHMI, ET AL.)	
		:	Group Art Unit: 2828
Application No.: 09/531,958)	
		:	
Filed: March 21, 2000)	
		:	
For:	LASER OSCILLATING)	
	APPARATUS EXPOSURE	:	
	APPARATUS, AND DEVICE)	
	FARRICATION METHOD		Date: November 18, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REQUEST FOR CONSIDERATION OF INFORMATION DISCLOSURE STATEMENT

Sir:

Applicants have not yet received an indication that the art cited in the Information Disclosure Statements dated May 25, 2000 and August 9, 2003 has been made of record.

It is respectfully requested that the Examiner indicate that the art has been made formally of record. Since the Information Disclosure Statements were filed in conformity with the applicable rules and guidelines, Applicants assume that it has been considered.

Applicants' undersigned attorney may be reached in our Costa Mesa,

California office at (714) 540-8700. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

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